

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Venkat Selvamanickam, et al.

Title: APPARATUS FOR HIGH-THROUGHPUT ION BEAM-ASSISTED
DEPOSITION (IBAD)

App. No.: 10/602,467

Filed: June 23, 2003

Examiner: Brian K. Talbot

Group Art Unit: 1762

Customer No.: 34456

Confirmation No.: 2664

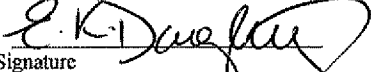
Atty. Dkt. No.: 1014-SP103

MS RCE
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Dear Sir:

In response to the Office Action mailed November 30, 2008, please amend the above-identified application as follows:

CERTIFICATE OF TRANSMISSION/MAILING	
I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to the Commissioner for Patents on <u>02-29-08</u> .	
<u>Elise K. Dougherty</u>	
Typed or Printed Name	Signature